

IFW AF/2675
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hisashi NAKAMURA et al.**

Group Art Unit: 2675

Serial Number: 10/073,959

Examiner: **Ming Hun Liu**

Filed: **February 14, 2002**

PTO Confirmation No.: 8711

For: **LIQUID CRYSTAL PROJECTOR COOLING SYSTEM DEPENDENT ON
AIR PRESSURE AND TEMPERATURE VARIABLES**

Attorney Docket No.: 042288

Customer No.: 38834

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

October 18, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 19, 2004 for three months from July 19, 2004 to October 19, 2004.

Attached please find a check in the amount of \$980.00 to cover the cost of the extension for a large entity. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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By: 

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Attachments: Fees - \$980.00

Notice of Appeal w/fee

MJC/SMD/rer